'Receipt date: 10/21/2008

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10/593557 IAP9/Rec'd PCT/PTO 20 SEP 2006 8075-1111

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Yasuhiko KASAMA et al.

Conf.: Unassigned

Application No.: NEW NATIONAL PHASE

Group: Unassigned

Filed: September 20, 2006

Examiner: Unassigned

FOR: PRODUCTION METHOD OF MATERIAL FILM AND PRODUCTION APPARATUS

OF MATERIAL FILM

INFORMATION DISCLOSURE STATEMENT (SUBMISSION CONCURRENT WITH THE FILING OF A NEW PATENT APPLICATION)

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 20, 2006

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, and in fulfillment of the duty of disclosure under 37 C.F.R. § 1.56, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications, or other information submitted for consideration by the Office are listed on PTO-1449, attached hereto.

II. COPIES

- Copies of the U.S. patents or publications are not submitted since the USPTO has waived their submission for applications filed after June 30, 2003.
- Submitted herewith is a legible copy of (i) each foreign patent; (ii) each publication or that portion which caused it to be listed; and (iii) all other information or that portion which caused it to be listed.
- This application is a National Phase of a PCT application. Some or all of the documents listed on the PTO-1449 are not enclosed because they were cited in the International Search Report and copies should have been forwarded from the International Search Authority pursuant to the trilateral agreement between the USPTO, EPO and JPO, or they are U.S. patents or U.S. published applications. If copies are needed, please contact the undersigned.

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III.		EXPLANATION		RELEVANCE		
	(check a	at least one	box)			

а.	\Box	DOCUMENTS	TN	THE	ENGLISH	T.ANGUAGE
a.		DOCOMENIA	T 1.4	TUE	FIGHTOU	THIRDONGE

The attached non U.S. patents, non U.S. patent application publications, foreign publications, or other information in the English language do not require a statement of relevancy.

b. DOCUMENTS NOT IN THE ENGLISH LANGUAGE

A concise explanation of the relevance of all patents, publications, or other information listed that is not in the English language is as follows:

An English language version of the search report or action that indicates the degree of relevance found by the foreign office is attached, thereby satisfying the requirement for a concise explanation. See MPEP 609(A)(3).

d. Tother

The following additional information is provided for the Examiner's consideration.

FEES

This Information Disclosure Statement is being filed concurrently with the filing of a new patent application; therefore, no fee is required.

If The Examiner has any questions concerning this IDS, he/she is requested to contact the undersigned.

Respectfully submitted,

YOUNG & THOMPSON

Benoit Castel, Reg. No. 35,041 745 South 23rd Street

Benoît Castel

745 South 23rd Street Arlington, VA 22202 Telephone (703) 521-2297

Telefax (703) 521-2297 Telefax (703) 685-0573

(703) 979-4709

BC/sj

Enclosures:

☐ Form PTO-1449(s)

□ Documents

Other:_____

INFO	pt date: 10/21/2008 INFORMATION DISCLOSURE CITATION		Attorney Docket No.: 8075-1111		SEP 2006 Sheet 1 of Application No.: NEW NATIONAL PHA				
	IN AN APPLICATION	ON	Applicant: Yasuhiko KASAMA et al.						
	(Use several sheets if necessary)		Filing Date: September 20, 2006		Group Art Unit:				
		U.S. PATE	NT DOCUMENTS						
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* English language abstract provided for the Examiner's convenience

Y&T September 20, 2006